

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	133	substrate same magnetic same holder same actual \$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:41
L2	5	substrate same magnetic same holder same actual \$4 same wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:42
L3	275	substrate same magnetic same holder same wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:44
L4	106	substrate same magnetic same holder same wafer and sputtering	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:47
L5	18	substrate same magnetic same holder same wafer and sputtering not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:48
L6	289	substrate holder same wafer and sputtering not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:49
L7	8	substrate holder same magnetic same wafer and sputtering not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:49
L8	24	magnetic chuck same substrate and vacuum not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:51
L9	2	magnetic chuck same sputtering not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:07

L10	20	"118".clas. and magnetic chuck	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:07
L12	6	"3977806"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:09
L14	3545	sputtering same cvd same ion same etching	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:56
L15	1237	sputtering same cvd same ion same etching and @py< "2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:57
L16	107	"118".clas. and sputtering same cvd same ion same etching and @py< "2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:57
L17	3187	118/728.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:34
L18	261	118/728.ccls. and @py< "2003" and magnetic	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:34
L19	1260	118/52.ccls. and @py< "2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:34
L20	1560	269/21.ccls. and @py< "2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:34
L21	21	269/21.ccls. and @py< "2003" and clip and spring	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:35

S1	556	(matsumoto near2 takafumi).in. or (mikami near2 shun).in. or (hanzawa near2 kouichi).in. or (moriya near2 mineharu).in. or (odagi near2 nideyuki).in. or (shimada near2 tetsuya).in. or (kubo near2 masashi).in. or (iked a near2 susumu).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:28
S3	442	((matsumoto near2 takafumi).in. or (mikami near2 shun).in. or (hanzawa near2 kouichi).in. or (moriya near2 mineharu).in. or (odagi near2 nideyuki).in. or (shimada near2 tetsuya).in. or (kubo near2 masashi).in. or (iked a near2 susumu).in.) and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:29
S4	4	"6231732".pn. or "5421979".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:32
S5	8583	substrate same jig and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:39
S6	156	rotary same substrate same jig and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:39
S7	26	rotary same releasable same jig and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:43

S8	18	releasable same substrate same jig and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:44
S9	0	wafer an dreasable same substrate same jig and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:45
S10	11	wafer and releasable same substrate same jig and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:45
S11	14	wafer and release same substrate same jig and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:45
S12	13	wafer and release same substrate same clip and @py< "2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:50
S13	2	"5421979".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 15:04
S20	1127	motor same actuate \$4 same electric signal	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 10:51
S21	746	motor same actuate \$4 same electric signal same control	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 10:51
S22	41	motor near10 actuate\$4 near10 electric signal same control	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 10:52
S26	6	releasable same substrate holder and wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 11:06
S28	55	electric signal near7 actuate near7 motor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 11:12
S34	134	(fukushima near2 chikayasu).in. or (yamamura near2 kazuichi).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 12:45

S35	243	substrate holder same jig	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 12:54
S36	103	substrate holder same jig	US-PGPUB; USPAT	ADJ	ON	2010/05/05 12:54
S37	103	substrate holder same jig and jig	US-PGPUB; USPAT	ADJ	ON	2010/05/05 12:59
S38	127	(asakawa near2 teruo).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:07
S41	61	"269".clas. and jig and @py< "2006" and wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:23
S42	259	"269".clas. and @py< "2006" and spring same release same push	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:28
S43	356	"269".clas. and @py< "2006" and spring same release same press	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:37
S44	26	"269".clas. and @py< "2006" and spring same release same wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:49
S49	38	"269".clas. and @py< "2006" and spring same plunger same vacuum	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 14:22
S50	87	"269".clas. and @py< "2006" and spring same plunger and vacuum	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 14:22

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